2877

Practitioner's Docket No.: KLA-00

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Janik, Gary R. et al.

Assignee:

**KLA-Tencor Corporation** 

Title:

Laser-Based Cleaning Device for Film Analysis Tool

Serial No.:

10/056,271

Art Unit.: 2877

Filed:

January 23, 2002

Examiner: Gordon J. Stock, Jr.

March 24, 2004

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the outstanding Office Action dated February 24, 2004, in which the Examiner imposed a restriction requirement to election of invention for the above-referenced application, Applicant elects to prosecute the invention as in Claims 21, 24, 44, and 47, which are drawn to Species 1 (see remarks on species characterization below). Applicant reserves the right to file divisional applications on the non-elected claims.

However, Applicants respectfully traverse the Examiner's characterization of both Species 1 and Species 2. With regard to Species 1, the Examiner states that "Figs. 2a and 2b are directed to ... a film analysis system comprising an optically based module that performs a two-step film analysis process." (Emphasis added.) However, as described in the specification as originally filed at page 10, paragraph 0024:

For explanatory purposes, Fig. 2b depicts analysis module 240 as including a xenon lamp 241, a rotating polarizer 242, a focusing mirror 243, a fixed polarizer 244, a spectrometer 245, and a CCD detector 246 for performing a spectroscopic ellipsometry analysis. However, analysis module 240 can comprise a system or systems for any type of analysis that would benefit from removal of contaminant layer 213, including SWE, SE, reflectometry (optical or x-ray), GXR, XRF, EMP, and non-contact or contact-based electrical analysis, among others. (Emphasis added.)

Thus, the "two-step analysis process" of Species 1 is explicitly not limited to optical analyses.

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Similarly, while the Examiner states that with regard to Species 2, "Figs. 3a and 3b are directed to ... a film analysis system comprising an electrically based analysis module that performs a three-step film analysis operation," the specification as originally filed at page 14, paragraph 33 states that:

However, analysis module 340 can comprise a system or systems for any type of analysis that would benefit from removal of contaminant layer 313, including SWE, SE, reflectometry, GXR, XRF, EMP, and non-contact or contact-based electrical analysis, among others. (Emphasis added.)

Thus, the "three-step film analysis" of Species 2 is explicitly <u>not</u> limited to "electrically based" analyses.

In summary, neither Species 1 nor Species 2 in the present application are limited to a particular analysis type. Accordingly, while the Examiner states that "[c]urrently, claims 1, 8-13, 15-19, 27-28, 35, 41-43, and 50 are generic," it is submitted that Claims 1-20, 27-37, 41-43, and 50 are generic. Applicants respectfully request that the Examiner provide an updated characterization of Species 1 and 2 in light of the above remarks.

Respectfully submitted,

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I hereby certify that this correspondence is being deposited with the United States Postal Service as FIRST CLASS MAIL in an envelope addressed to: Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 24, 2004.

Date

Signature: Rebecca A. Baumann